## IN THE CLAIMS:

Claims 1-18 (Canceled).

- 19. (Original) A heterojunction bipolar transistor comprising:
- a collector;
- a base disposed above the collector, the base comprising a silicon-germanium layer;
- a germanium-enriched region proximate an upper surface of the base and within the silicongermanium layer; and

an emitter overlying the germanium-enriched region.

- 20. (Original) The heterojunction bipolar transistor of claim 19 wherein the germanium-enriched region creates a band-gap differential between the emitter and the base.
- 21. (Original) The heterojunction bipolar transistor of claim 19 wherein carrier mobility is greater in the germanium-enriched region than in the base.
- 22. (Original) The heterojunction bipolar transistor of claim 19 wherein the germanium-enriched region comprises a strained germanium-enriched region.
- 23. (Original) The heterojunction bipolar transistor of claim 19 wherein a germanium concentration in the germanium-enriched region ranges from about 30 percent to about 75 percent.
- 24. (Original) The heterojunction bipolar transistor of claim 19 wherein a germanium concentration is greater in the germanium-enriched region than in the silicon-germanium layer.
- 25. (Original) The heterojunction bipolar transistor of claim 19 having a valence band offset of greater than about 0.21 eV.
- 26. (Original) The heterojunction bipolar transistor of claim 19 wherein the germanium-enriched region has a relatively low level of lattice defects.
- 27. (Original) The heterojunction bipolar transistor of claim 19 wherein the base comprises a graded doped silicon-germanium base or a stepped doped silicon-germanium base.
- 28. (Original) The heterojunction bipolar transistor of claim 19 wherein the base comprises a uniformly doped silicon-germanium base.
  - 29. (Original) The heterojunction bipolar transistor of claim 19 wherein the germanium-

enriched region is in contact with the emitter.

- 30. (Original) The heterojunction bipolar transistor of claim 19 wherein a concentration of germanium in the germanium-enriched region decreases abruptly from a concentration proximate the upper surface in a direction toward the collector.
  - 31. (Currently Amended) A bipolar junction semiconductor comprising:
  - a silicon substrate;
  - a collector disposed in the substrate;
- a base disposed overlying the collector, wherein the base comprises a silicon-germanium portion;
- a germanium-enriched region formed <u>proximate an upper surface of the base</u> in the silicongermanium portion, wherein a concentration of germanium in the germanium-enriched region is substantially greater than the concentration of germanium in the silicon-germanium portion; and an emitter disposed overlying the germanium-enriched region
- 32. (Original) The bipolar junction semiconductor of claim 31 wherein the germanium-enriched region comprises a thermally oxidized enriched region.
- 33. (Original) The bipolar junction semiconductor of claim 31 wherein the germanium enriched region includes at least a 30% germanium concentration.